

Effect of bonding parameters on microstructure and properties of $\text{Si}_3\text{N}_4/\text{Si}_3\text{N}_4$ joint brazed by $\text{Cu}\text{Zn}\text{Ti}$ filler alloy^①

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Abstract: Si_3N_4 ceramic was jointed to Si_3N_4 ceramic using a filler alloy of $\text{Cu}\text{Zn}\text{Ti}$ at 1123–1323 K for 0.3–2.7 ks. Ti content in the $\text{Cu}\text{Zn}\text{Ti}$ filler alloy was 15% (molar fraction). The effect of bonding parameters on the microstructure and mechanical properties of the $\text{Si}_3\text{N}_4/\text{Si}_3\text{N}_4$ joint were investigated. The results indicate that with increasing brazing temperature from 1123 K to 1323 K and brazing time from 0.3 ks to 2.7 ks, the thickness of the interfacial reaction layer between the filler alloy and the Si_3N_4 ceramic and the size and amount of the reactant products in the filler alloy increase, leading to an increase in shear strength of the joint from 163 MPa to 276 MPa. It is also found that the fracture behavior of the $\text{Si}_3\text{N}_4/\text{Si}_3\text{N}_4$ joint greatly depends on the microstructure of the joint.

Key words: Si_3N_4 ceramic; $\text{Cu}\text{Zn}\text{Ti}$ filler alloy; bonding parameters; microstructure; mechanical property

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1 INTRODUCTION

Si_3N_4 ceramic has high thermal and wearing resistance and is a promising material for high temperature applications. However, it is difficult to manufacture the Si_3N_4 ceramic workpieces with larger dimensions and complicated shapes due to its poor workability and low ductility. In recent 20 years, many studies have been focused on the techniques of ceramic joining, because the joining techniques can be used not only for low-cost and high-reliability manufacturing of ceramic parts with complicated shapes but also for repairing of the ceramic parts in which some cracks exist.

Various methods have been adopted for ceramic joining, including diffusion bonding^[1], oxynitride glasses joining^[2], anodic bonding^[3], joining via functional gradients^[4], brazing^[5-7], microwave bonding^[8] and partial transient liquid phase bonding^[9, 10]. During diffusion bonding process, metal interlayer is used for bonding between ceramics or bonding between ceramic and metal. A joint with high bonding strength and corrosion resistance can be obtained with a large bonding area by the diffusion bonding. However, it requires surface treatment, long bonding time and larger equipment for bonding larger parts. Because of a very sharp interface, a larger residual stress exists, resulting in

a decrease of bonding strength. The structure of joint obtained by oxynitride glass joining is similar to the ceramic substrate, resulting in a lower residual strength and a higher bonding strength. However, this method cannot be used for bonding between different ceramics or between ceramic and metal. Anodic bonding, microwave bonding and joining via functional gradients were developed and studied later and used for limited material systems. Partial transient liquid phase bonding is a promising technique to obtain thermal resistance ceramic joint at lower bonding temperature. Active metal brazing is widely investigated because it is a simple process to obtain high strength ceramic joints with different shapes and sizes^[11, 12]. For the active metal brazing of Si_3N_4 ceramic, it is important to find a suitable filler alloy to improve the properties of the joints. In this investigation, a $\text{Cu}\text{Zn}\text{Ti}$ alloy was used as the filler alloy for the active metal bonding of the Si_3N_4 ceramic. The effect of brazing parameters on the properties of the $\text{Si}_3\text{N}_4/\text{Si}_3\text{N}_4$ joint was investigated, and the fracture behavior of the joint was analyzed.

2 EXPERIMENTAL

Si_3N_4 ceramic used in this investigation was made by a pressureless sintering process. The con-

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tents of MgO and Al_2O_3 in the ceramic were less than 5% (mass fraction). $\text{Cu}65\text{Zn}35$ alloy foil with a thickness of 0.1 mm and Ti foil with a thickness of 20 μm were used as filler materials to braze the Si_3N_4 ceramic. The Cu-Zn-Ti alloys contained 15% Ti (molar fraction). The brazing of the Si_3N_4 ceramic was carried out in a vacuum of 1.33×10^{-3} Pa under a pressure of 2×10^{-3} MPa. The brazing temperature was from 1 123 K to 1 323 K with an interval of 50 K. The brazing time was from 0.3 ks to 2.7 ks.

The Si_3N_4 ceramic sample with a size of $6\text{ mm} \times 3\text{ mm}$ was ground to a surface roughness of $R_a = 30\text{ }\mu\text{m}$, and then was cleaned together with the metal foils in a supersonic device. The cleaned metal foils were placed between two pieces of Si_3N_4 ceramic samples and a small pressure was put on the upper ceramic sample. The brazing was carried out in a vacuum furnace. The assembly was heated at a rate of 30–40 K/min and cooled in the furnace to room temperature. The microstructure of the joints was observed by EPMA, and the shear strength of the $\text{Si}_3\text{N}_4/\text{Si}_3\text{N}_4$ joint was measured at room temperature.

3 RESULTS

3.1 Microstructure of joint

EPMA image and elemental distribution of the $\text{Si}_3\text{N}_4/\text{Si}_3\text{N}_4$ joint brazed at 1 223 K are shown in Figs. 1(a) and (b), respectively. There are three zones in the joint. Zone I is a continuous layer near the Si_3N_4 ceramic containing mainly Ti and N and a small amount of Si, Cu and Zn. Zone II contains mainly Cu and some Zn and a small amount of Ti. In the zone III compared with zone II, the amount of Cu decreases and that of Ti increases. There is no Si and N in the zone II and zone III. The compositions of the three zones are listed in Table 1. Based on Ti-N and Cu-Zn-Ti phase diagrams^[13, 14], it is considered that the reaction layer of the zone I is composed of titanium nitride (TiN) and titanium silicide. Zone II is composed of Cu-Zn solid solution containing a small amount of Ti. Zone III consists of Cu_2TiZn phase.

Table 1 Compositions of different zones in joint brazed at 1 223 K for 0.9 ks using (CuZn) 85Ti15 filler alloy (molar fraction, %)

Position	Si	Ti	Cu	Zn	N
Zone I	13.90	61.27	5.70	0.61	18.52
Zone II	0.08	2.49	80.69	16.73	0
Zone III	0.07	24.54	61.21	13.44	0.73

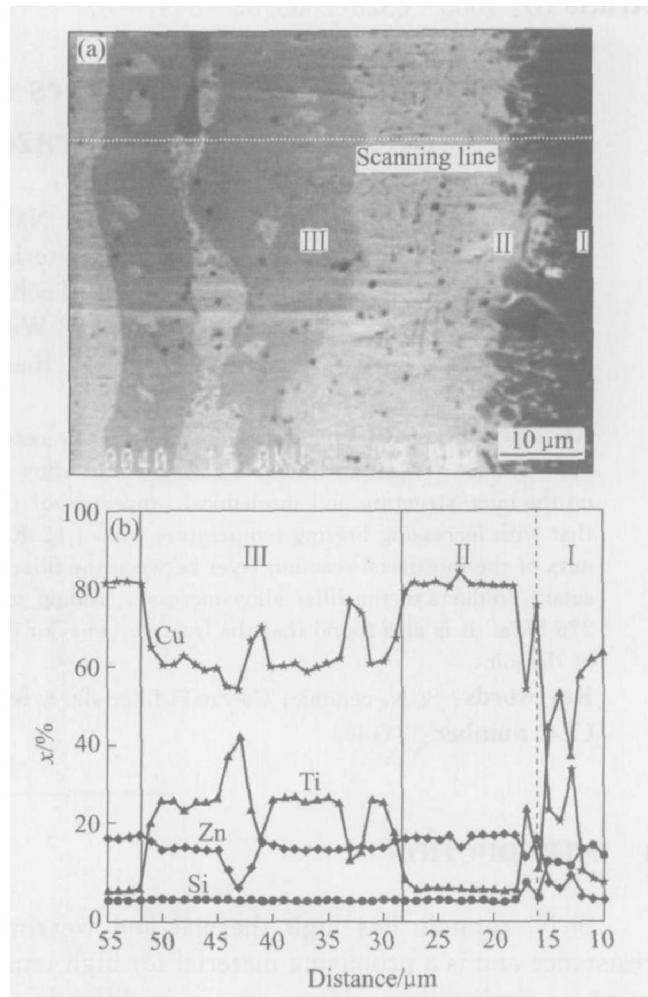


Fig. 1 Microstructure and elemental distribution of joint brazed at 1 223 K for 0.9 ks using (CuZn) 85Ti15 filler alloy
(a) —Microstructure of joint;
(b) —Elemental distribution of joint

3.2 Effect of brazing temperature on microstructure and properties of joint

Fig. 2 shows the morphologies of the $\text{Si}_3\text{N}_4/\text{Si}_3\text{N}_4$ joints brazed at different temperatures for 0.9 ks. It is indicated that when the brazing temperature is lower than 1 223 K, the joint contains TiN reaction layer, fine Ti_5Si_3 reactants and Cu-Zn solid solution containing Cu_2TiZn . When the brazing temperature is higher than 1 223 K, more and more Ti_5Si_3 phases appear in the Cu-Zn solid solution, and the amount of the Cu_2TiZn phase decreases. When the brazing temperature is 1 373 K, Cu_2TiZn phase disappears and the Ti_5Si_3 phase is the main phase in the joint. It is concluded that with increasing brazing temperature, the thickness of the TiN layer increases, meanwhile, the amount of Cu_2TiZn phase decreases and that of the Ti_5Si_3 phase increases.

During the brazing process, with increasing heating temperature, the deformability of the filler foils increases, leading to a tight connection between filler foil and Si_3N_4 ceramic. It is known

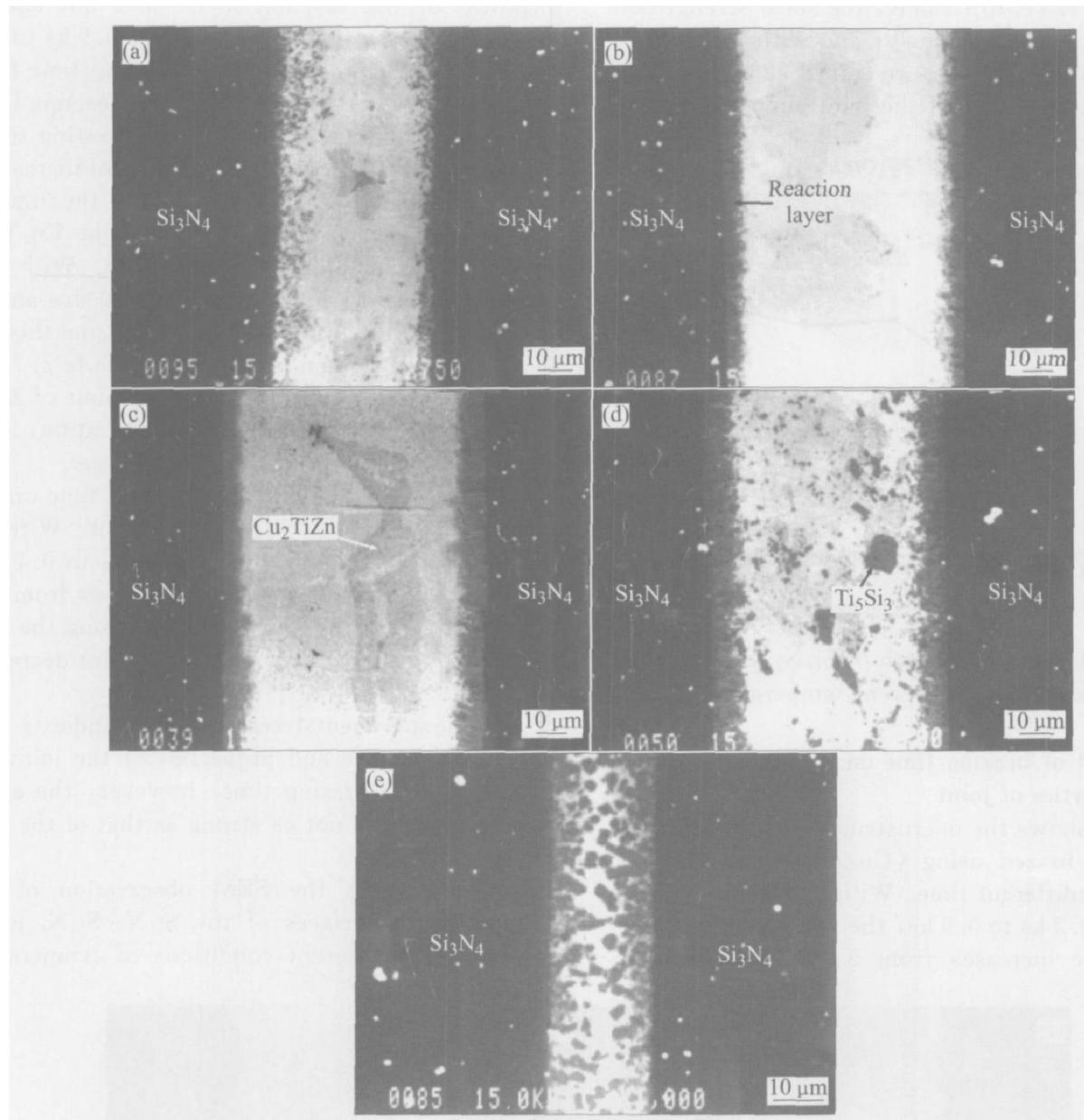


Fig. 2 Microphotographs of $\text{Si}_3\text{N}_4/\text{Si}_3\text{N}_4$ joints brazed using (CuZn) 85Ti15 filler alloy at different temperatures for 0.9 ks

(a) —1 1123 K; (b) —1 1173 K; (c) —1 1223 K; (d) —1 1273 K; (e) —1 1323 K

form Cu-Ti phase diagram that the eutectic temperature of Cu-22% Ti (molar fraction) alloy is 1148 K. When the heating temperature reaches 1100 K (melting point of brass), the Cu-Zn alloy begins to melt. When the heating temperature reaches 1148 K, Ti begins to dissolve into the Cu-Zn melt. At the brazing temperature of 1123 K used here, the filler alloy is in semisolid state, and there is also some solid Ti in the filler alloy, leading to a decreasing amount of Ti in the molten filler alloy. Because of the existence of solid Ti, the flowability of the filler alloy decreases and the diffusion speed of Ti in the filler alloy decreases. Therefore, in the $\text{Si}_3\text{N}_4/\text{Si}_3\text{N}_4$ joint brazed at 1123 K, the thickness of the TiN layer and the amount of the Ti_5Si_3 phase are little, meanwhile, Ti prefers to react with Cu and Zn to form Cu_2TiZn phase. With increasing brazing temperature, more and more Ti dissolves

into the molten Cu-Zn alloy. When the brazing temperature is higher than 1173 K, all the Ti dissolves into the Cu-Zn alloy and all the filler alloy becomes in molten state. With increasing brazing temperature, the flowability of the filler alloy increases and the speed of diffusion and reaction increases also, leading to an increasing thickness of the TiN reaction layer and an increasing amount of the Ti_5Si_3 phase. However, when the brazing temperature is higher than 1323 K, the flow speed of the filler alloy is so high that some molten filler flows out of the joint, leading to a decreasing amount of reacting elements and decreasing thickness of the reaction layer and the joint.

Fig. 3 shows the shear strength of the $\text{Si}_3\text{N}_4/\text{Si}_3\text{N}_4$ joints brazed at different temperatures for 0.9 ks using (CuZn) 85Ti15 as the filler alloy. It can be seen that with increasing brazing tempera-

ture from 1 123 K to 1 223 K, the shear strength of the joint increases obviously; and with further increasing brazing temperature from 1 223 K to 1 323 K, the shear strength of the joint almost does not change.

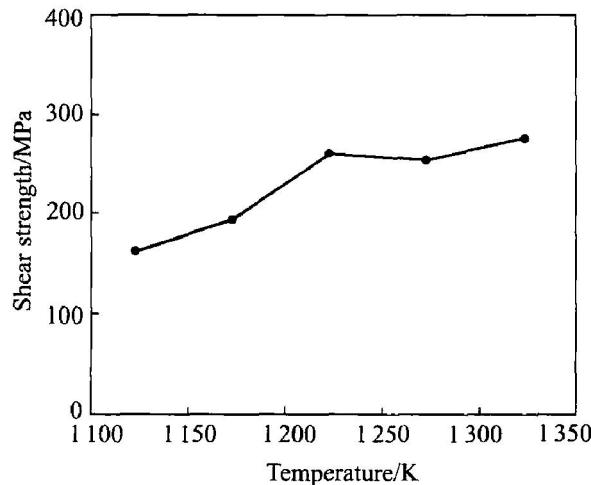


Fig. 3 Shear strength of $\text{Si}_3\text{N}_4/\text{Si}_3\text{N}_4$ joints brazed at different temperatures

3.3 Effect of brazing time on microstructure and properties of joint

Fig. 4 shows the microstructures of the $\text{Si}_3\text{N}_4/\text{Si}_3\text{N}_4$ joint brazed using (CuZn) 85Ti15 alloy at 1 223 K for different time. With increasing brazing time from 0.3 ks to 0.9 ks, the thickness of the reaction layer increases from 5 μm to 7 μm . The

thickness of the reaction layer does not change when the brazing time increases from 0.9 ks to 1.8 ks. With further increasing the brazing time from 1.8 ks to 2.7 ks, the thickness of the reaction layer increases to 10 μm . With increasing brazing time, the amount of Ti_5Si_3 reactant in the joint increases, but its size does not change. When the brazing time is shorter than 0.9 ks, a fiber-like Cu_2TiZn phase can be found clearly in the joint. With further increasing the brazing time, both size and amount of the Cu_2TiZn phase decrease, and this can be hardly found when the brazing time is 2.7 ks. With increasing brazing time, the amount of Zn in the joint decreases because of its evaporation, leading to the decrease of the Cu_2TiZn phase.

Fig. 5 shows the effect of brazing time on the shear strength of the $\text{Si}_3\text{N}_4/\text{Si}_3\text{N}_4$ joint. With increasing the brazing time from 0.3 ks to 0.9 ks, the shear strength of the joint increases from 197 MPa to 262 MPa. With further increasing the brazing time, the shear strength of the joint decreases a little.

The experimental results above indicate that the microstructure and properties of the joint are affected by the brazing time, however, the effect of brazing time is not as strong as that of the brazing temperature.

According to the SEM observation of the shear fracture surfaces of the $\text{Si}_3\text{N}_4/\text{Si}_3\text{N}_4$ joints brazed under different conditions of temperature

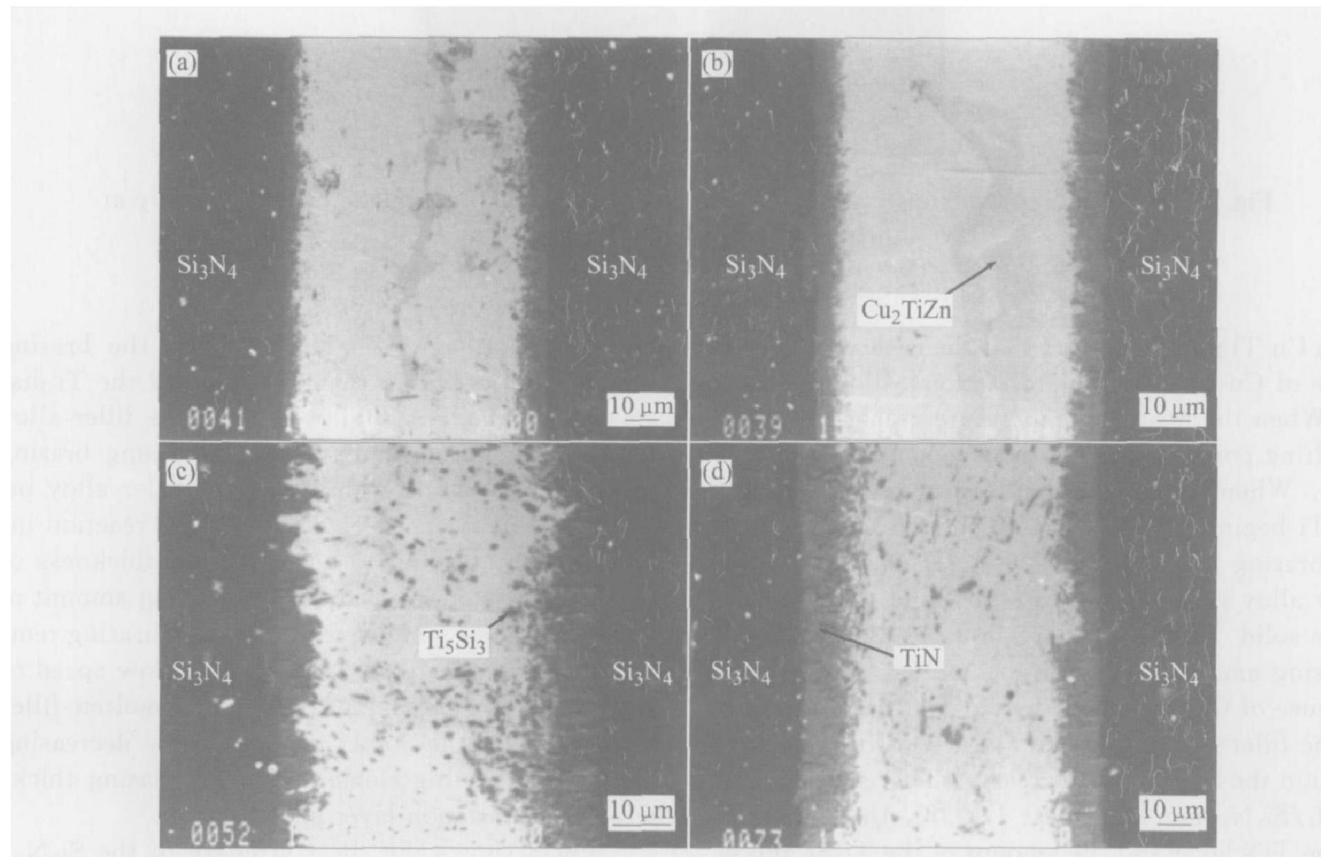


Fig. 4 Microstructures of $\text{Si}_3\text{N}_4/\text{Si}_3\text{N}_4$ joint brazed using (CuZn) 85Ti15 alloy at 1 223 K for different times
(a) —0.3 ks; (b) —0.9 ks; (c) —1.8 ks; (d) —2.7 ks

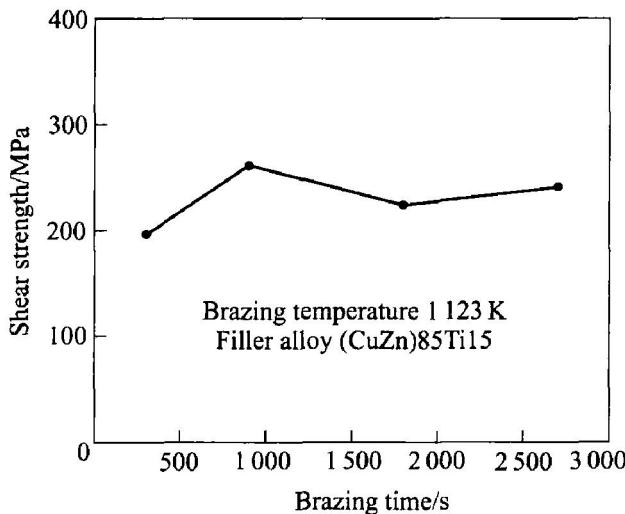


Fig. 5 Effect of brazing time on shear strength of $\text{Si}_3\text{N}_4/\text{Si}_3\text{N}_4$ joints

and time, the fracture models of the joints were analyzed and summarized, and four fracture models were set up, as shown in Fig. 6.

Model(I) shows that the fracture occurs between ceramic and reaction layer. Model(II) indicates that crack initiates within the Si_3N_4 ceramic adjacent to the brazing seam and propagates into the ceramic and then through the seam, and at the end of the fracture, the crack propagates in the ce-

ramic of the other side of the seam. Model(III) shows that the fracture occurs within the Si_3N_4 ceramic adjacent to the seam. Model(IV) indicates that crack initiates within the Si_3N_4 ceramic adjacent to the brazing seam and propagates towards the interface between ceramic and reaction layer. The shear fracture of the $\text{Si}_3\text{N}_4/\text{Si}_3\text{N}_4$ joints brazed in various parameters follows different models.

4 DISCUSSION

The mechanical properties of the $\text{Si}_3\text{N}_4/\text{Si}_3\text{N}_4$ joint depend on the microstructure of the joint. From Fig. 2, it can be seen that with increasing brazing temperature, the thickness of the reaction layer increases and the amount and size of the Ti_3Si_3 reactant products in the Cu-Zn solid solution increase too. While, the amount and size of the Cu_2TiZn reactant products decrease with increasing brazing temperature because of the increasing evaporation of Zn during brazing at higher temperatures^[15]. When the brazing temperature is lower than 1173 K, the thickness of the reaction layer is not large enough to get a strong bonding between the filler alloy and the Si_3N_4 ceramic, and in this case, crack initiates and propagates at the interface between the ceramic and the reaction layer(model (I)), corresponding to a lower shear strength of

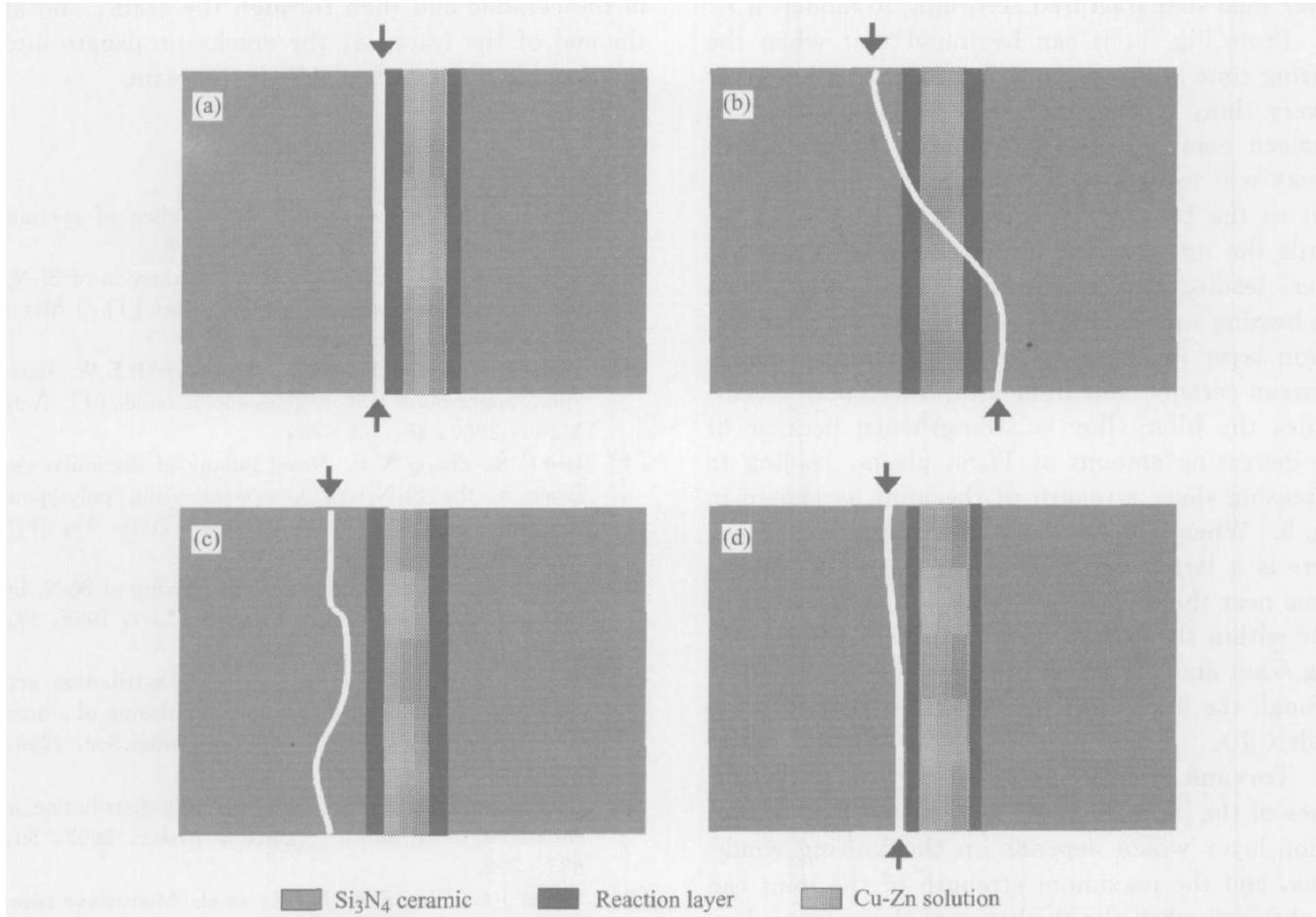


Fig. 6 Shear fracture models of $\text{Si}_3\text{N}_4/\text{Si}_3\text{N}_4$ joints
(a) —Model(I); (b) —Model(II); (c) —Model(III); (d) —Model(IV)

the joint. With increasing brazing temperature, the thickness of the reaction layer increases, resulting in the increasing bonding strength and load transfer ability of the joint. When the brazing temperature is 1 223 K, the shear fracture begins within the Si_3N_4 ceramic adjacent to the seam, and the crack propagates through the seam into the Si_3N_4 ceramic of the other side of the seam, leading to the fracture following the model(II). Because of the great difference in the thermal expansion coefficient between the Si_3N_4 ceramic and filler alloy, a residual stress exists in the Si_3N_4 ceramic near the seam during the cooling process from the brazing temperature. In the shear test, crack preferentially initiates in the Si_3N_4 ceramic where the residual tensile stress is the maximum, and then it propagates along the path shown in the model(II). In this case, the shear strength of the joint is the highest. When the brazing temperature is 1 273 K or 1 323 K, the thickness of the reaction layer is so large that the residual stress in the ceramic increases significantly. In this case, crack initiates and propagates along one side of the Si_3N_4 ceramic where the residual tensile stress is the maximum (model (III)). The shear strength of the joint brazed at 1 273 K is a little lower than that brazed at 1 223 K, indicating that the shear strength of the joint fractured according to model(III) is a little lower than that fractured according to model(II).

From Fig. 4, it can be found that when the brazing time is shorter(0. 3 ks), the reaction layer is very thin, leading to a lower bonding strength between ceramic and filler alloy. In this case, cracks will initiate within the Si_3N_4 ceramic adjacent to the brazing seam and then propagate towards the interface between ceramic and reaction layer, leading to a fracture like model(IV). When the brazing time is 0. 9 ks, the thickness of the reaction layer increases, and the bonding strength between ceramic and filler alloy increases. Meanwhile, the filler alloy is strengthened because of the increasing amount of Ti_5Si_3 phase, leading to increasing shear strength of the joint as shown in Fig. 5. When the brazing time is 0. 9 - 2. 7 ks, there is a larger residual tensile stress in the ceramic near the interface, therefore, cracks will initiate within the Si_3N_4 ceramic adjacent to the brazing seam and propagates in the ceramic and then through the seam, leading to a fracture following model(II).

Torvund et al^[16, 17] pointed out that the properties of the joint relate to the thickness of the reaction layer which depends on the brazing conditions, and the maximum strength of the joint can be obtained when the thickness of the reaction layer has a moderate value. The experimental results of this investigation correspond to that pointed out

by Torvund et al.

5 CONCLUSIONS

Shear strength and fracture behavior of the $\text{Si}_3\text{N}_4/\text{Si}_3\text{N}_4$ joints brazed using Cu-Zn-Ti as the filler alloy depend on the microstructure of the joints, which are affected by brazing temperature and time. Shear strength of the joint increases with increasing brazing temperature, when the brazing time is 0. 9 ks and $(\text{CuZn})85\text{Ti}15$ is used as the filler alloy. When the brazing temperature is lower than 1 173 K, the fracture takes place at the interface between the ceramic and the reaction layer. With increasing brazing temperature (up to 1 223 K), the shear fracture begins within the Si_3N_4 ceramic adjacent to the brazing seam, and then the crack propagates through the seam into the Si_3N_4 ceramic of the other side of the seam. With further increasing brazing temperature (1 273 K and above), the shear fracture occurs within one side of the Si_3N_4 ceramic adjacent to the seam. When the brazing time is 0. 3 ks, cracks initiate within the Si_3N_4 ceramic adjacent to the brazing seam and then propagate towards the interface between ceramic and reaction layer. When the brazing time surpasses 0. 9 ks, cracks initiate within the Si_3N_4 ceramic adjacent to the brazing seam and propagate in the ceramic and then through the seam, and at the end of the fracture, the cracks propagate into the ceramic of the other side of the seam.

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